


FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office * INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. 843.39875X00	SERIAL NO. Not assigned	J1040 U.S. PTO 09/805056 
	APPLICANT T. MIYAMOTO		
	FILING DATE March 14, 2001	GROUP Not assigned	

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

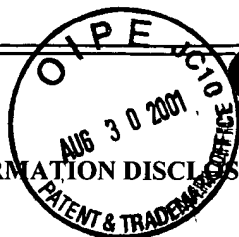
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Ashe Kumar Sachar

DATE CONSIDERED
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(Rev. 8-83)U.S. Department of Commerce
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Atty Docket 0819-0560

Serial No. 09/865,546

INFORMATION DISCLOSURE STATEMENT

Applicants: Taiji NODA

Filing Date: May 29, 2001

Group Art Unit: 2812

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner
Initial

AKS

Noda et al., "Effects of End-of-Range Dislocation Loops on Transient Enhanced Diffusion of Indium Implanted in Silicon", pp. 4980-4984, November 1, 2000, Journal of Applied Physics, Vol. 88, No. 9

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Examiner

Asoh Ummer Sarhan

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08/29/2001